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**RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE--EXAMINING GROUP 2812**

Attorney Docket No. 5649-1055

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Park et al.

Examiner: H. Jey Tsai

Serial No.: 10/615,362

Group Art Unit: 2812

Filed: July 8, 2003

Confirmation No.: 8781

For: METHODS FOR FORMING A METAL CONTACT IN A SEMICONDUCTOR DEVICE IN WHICH AN OHMIC LAYER IS FORMED WHILE FORMING A BARRIER METAL LAYER

Date: January 28, 2005

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

Sir:

Applicants provide the present Amendment to address the issues raised in the Final Office Action mailed October 28, 2004.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

It is not believed that an extension of time and/or additional fee(s)-including fees for net addition of claims-are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.